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41,733  
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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

Applicant : Alain Izadnegahdar et al.  
Serial No. : 09/908,847  
Filed : July 20, 2001  
Title : THIN PIEZO RESISTIVE PRESSURE SENSOR  
Docket No. : 015559-250  
Art Unit : 2855

Commissioner for Patents  
Washington, D.C. 20231

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JUN 07 2004  
TECHNOLOGY CENTER R3700

### INFORMATION DISCLOSURE STATEMENT

Pursuant to 37 C.F.R. §1.56, the Examiner's attention is directed to the references listed on the attached Information Disclosure Citation, copies of which are attached.

It is to be understood that the present submission of art is in no way intended to be a waiver of any arguments or defenses available to the applicant under the rules of the U.S. Patent and Trademark Office and the statutes of the United States.

No fee is required. The Commissioner is authorized to charge any additional fees required by this paper or to credit any overpayment to Deposit Account No. 20-0809.

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INFORMATION DISCLOSURE CITATION

Page 1 of 2 Pages



Docket: 015559-250

Serial. No.: 09/909,847

Applicant: Alain Izadnegahdar et al.

Filed: 7/20/01

Group: 2855

U.S. PATENT DOCUMENTS

Examiner	Document No.	Date	Name	Class	Sub	
	4,023,562	05/77	Hynecek et al.			
	4,882,933	11/89	Petersen et al.			
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FOREIGN PATENT DOCUMENT

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Examiner	Document No.	Date	Country	Class	Sub	Y	N	

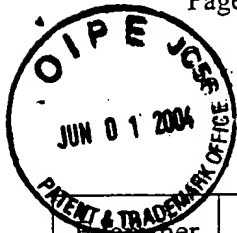
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	E. Kälvesten, <i>The First Surface Micromachined Pressure Sensor for Cardiovascular Pressure Measurements</i> , <u>IEEE</u> , pp. 574-579 (1998)
	Hin-Leung Chau, <i>An Ultraminiature Solid-State Pressure Sensor for a Cardiovascular Catheter</i> , <u>IEEE Transactions on Electron Devices</u> , Vol. 35, No. 12, pp. 2355-2362 (1988)
Examiner:	Date Considered:

\* Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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